

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	SOPHIE et al.	)	Group Art Unit: 2	2812
App. No.	:	09/975,466	)		
Filed	:	October 9, 2001	)		
For	:	IN SITU REDUCTION OF COPPER OXIDE PRIOR TO SILICON CARBIDE DEPOSITION	)		ž.m.
Examiner	:	Unknown	)		

## **INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents Washington, D.C. 20231

Dear Sir:

Enclosed is form PTO-1449 listing thirty-seven (37) references that are also enclosed. This Information Disclosure Statement is being filed within three months of the filing date of this application or upon filing if this is a CPA or RCE, and no fee is required in accordance with 37 C.F.R. § 1.97(b)(1), (b)(2), or (b)(4).

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: January 8, 2007

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